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Attorney Docket No.: P/2850-120

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re Patent Application of

New York, New York

Toshinori Ota et al.

Date: August 29, 2006

Serial No.: 10/555,855

Group Art Unit: 1753

Filed: November 7, 2005

Examiner: ---

For: THERMOELECTRIC SEMICONDUCTOR MATERIAL, THERMOELECTRIC  
SEMICONDUCTOR ELEMENT USING THERMOELECTRIC SEMICONDUCTOR  
MATERIAL, THERMOELECTRIC MODULE USING THERMOELECTRIC  
SEMICONDUCTOR ELEMENT AND MANUFACTURING METHOD FOR SAME

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Respectfully submitted,

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RCF:bar  
Enclosures



<b>APPLICANT'S ART CITATION</b> (Use several sheets if necessary)		Application 10/555,855		OFGS File No. P/2850-120			
		Applicant Toshinori OTA et al.					
		Filing Date November 7, 2005		Group Art Unit 1753			
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Examiner	Date Considered
EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP § 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to the applicant.	